

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re patent application of

Min-Young HEO et al.

Serial No. 09/480,689

Filed: January 11, 2000

Attorney Docket No: 6192.0102/AA

Group Art Unit: 2814

Examiner: S. Rao

For: SYSTEM AND METHOD FOR MOVING
SUBSTRATES IN AND OUT OF A
MANUFACTURING PROCESS

Assistant Commissioner for Patents
Washington, D.C. 20231

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REPLY AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action mailed on August 29, 1999, Applicants submit the following Amendment and Remarks.

A three (3) month Petition for Extension of Time accompanies this Reply and Amendment. If the Commissioner determines that a three-month extension is not sufficient to comply with the requirements of the U.S. Patent and Trademark Office, the Commissioner is hereby authorized to charge any additional fees or credit any overpayment of fees to our Deposit Account No. 23-1951.

AMENDMENTS

Please cancel claims 1-6 without prejudice or disclaimer.

Below is presented a clean copy of the pending claims. A marked-up version of the claims showing any amendments is attached.

1 7 (Amended). A method for moving substrates in and out of a manufacturing process
2 using a system comprising an automatic transfer device for automatically transferring a

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2
A1